### **Application Data She t**

#### **Application Inf rmation**

Application Type:: Regular

Subject Matter:: Utility

Suggested Group Art Unit:: N/A

CD-ROM or CD-R?:: None

Sequence submission?:: None

Computer Readable Form (CRF)?:: No

Title:: MULTILEVEL SEMICONDUCTOR

MEMORY, WRITE/READ METHOD

THERETO/THEREFROM AND STORAGE

MEDIUM STORING WRITE/READ

**PROGRAM** 

Attorney Docket Number:: 21737-00013-US1

Request for Early Publication?:: No

Request for Non-Publication?:: No

Total Drawing Sheets:: 10

Small Entity?:: No

Petition included?::

Secrecy Order in Parent Appl.?:: No

#### **Applicant Information**

Applicant Authority Type:: Inventor

Primary Citizenship Country:: Japan

Status:: Full Capacity

Given Name:: Katsuki

Family Name:: Hazama

City of Residence:: Tokyo-to

Country of Residence:: Japan

Street of mailing address:: c/o Nippon Steel Corporation

6-3, Otemachi 2-chome

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City of mailing address::

Chiyoda-ku, Tokyo-to

State or Province of mailing address::

Country of mailing address::

Japan

### **Correspondence Information**

Correspondence Customer Number::

30678

# Representative Information

Representative Customer Number::

30678

## **Domestic Priority Information**

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	Divisional of	09/438,295	11/12/1999
This Application	Divisional of	08/931,519	09/16/1997

# **Foreign Priority Information**

Country::	Application number::	Filing Date::	Priority Claimed::
Japan	267844	09/18/96	Yes
Japan	342663	12/06/96	Yes

## **Assignee Information**

Assignee name::

Nippon Steel Corporation

6-3, Otemachi 2-chome

Chiyoda-ku, Tokyo-to, JAPAN

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